Enterin Pere

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IN THE CLAIMS

Please amend the following claims as indicated:

1. (Previously Presented) Apparatus for electro-chemical deposition on a substrate, comprising:

an annular contact ring;

one or more electrical contact pads disposed on the contact ring;

a first seal disposed inward of the electrical contact pad and providing a seal with the contact ring;

a thrust plate adapted to move axially relative to the contact ring;

a second seal coupled to a side of the thrust plate facing the contact ring; and wherein the first seal further comprises:

a base disposed in a groove at least partially formed in the contact ring; and

a lip extending from the base and flaring radially outward towards the contact pads, the lip having at least one sealing surface.

2. (Cancelled)

- 3. (Previously Presented) The apparatus of claim 1, wherein the lip further comprises:
 - a first sealing surface adapted to seal with the substrate; and
 - a second sealing surface adapted to seal with the contact ring.
- 4. (Original) The apparatus of claim 1, wherein the contact ring further comprises:
 - a first surface:
 - a shoulder coupled to the first surface;